

Citation List

Patent Literature

[0003]

[PTL 1] Japanese Unexamined Patent Publication No.
2016-115195

Summary of Invention

Technical Problem

[0004]

In the technology disclosed in PTL 1, while the process value can be displayed in a time-series graph, determining whether the operation state of the plant is normal or abnormal may be difficult with only a single type of graph.

[0005]

Embodiments of the present invention provide a display device, a display method, a control device, a control method, and a computer program that can display an operation state of a plant using a plurality of graphs and that can contribute to analysis of the operation state from various viewpoints.

Solution to Problem

[0006]

operator in the past. Accordingly, it is possible to learn about a monitoring point, and it is possible to easily improve an operation skill level.

Advantageous Effects of Invention

[0018]

According to embodiments of the present invention, it is possible to provide a display device, a display method, a control device, a control method, and a computer program that can display an operation state of a plant using a plurality of graphs and that can contribute to analysis of the operation state from various viewpoints.

Brief Description of Drawings

[0019]

Fig. 1 is a schematic diagram illustrating an overall configuration of a plant as a target to be monitored in an embodiment of the present invention.

Fig. 2 is a diagram illustrating a functional configuration of an operation support system in the embodiment of the present invention.

Fig. 3 is a diagram illustrating an example of a graph selection setting screen displayed on a display device according to the embodiment of the present invention.